Docket No.: 60188-652 PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277

Masafumi KUBOTA, et al. : Confirmation Number:

Serial No.: Group Art Unit:

Filed: September 16, 2003 : Examiner: Unknown

For: METHOD FOR FABRICATING SEMICONDUCTOR DEVICE

INFORMATION DISCLOSURE STATEMENT

Mail Stop IDS Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

The relevance of each reference listed on attached Form 1449 is discussed in the present specification.

Serial No.:

Please charge any shortage in fees due in connection with the filing of this paper, including

extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit

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Respectfully submitted,

MCDERMOTT, WILL & EMERY

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Facsimile: (202) 756-8087 Date: September 16, 2003

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SHEET 1 OF 1

INFORMATION DISCLOSURE CITATION IN AN APPLICATION (PTO-1449)				ATTY. DOCKET NO. 60188-652	SEF	SERIAL NO.		
				APPLICANT Masafumi KUBOTA, et al.				
				FILING DATE September 16, 200	GROUP			
			U.S. PATENT	DOCUMENTS				
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		EXAMINER			DATE CONSID	DERED		

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 809. Draw line through citation if not in conformance and not considered. include copy of this form with next communication to applicant. I Applicant is unique citation designation number (politional): 2 Applicant is to place a check mark here if English language Translation is attached.